



Docket No.: 50195-257

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
	:	
Norihiko KIRITANI	:	Confirmation Number: 7093
	:	
Serial No.: 09/817,154	:	Group Art Unit: 2823
	:	
Filed: March 27, 2001	:	Examiner: F. Toledo
	:	
For: METHOD FOR MANUFACTURING SILICON CARBIDE DEVICE AND OXIDATION FURNACE	:	

**PETITION FOR EXTENSION OF TIME**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

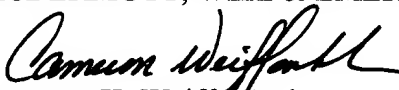
It is respectfully requested that the time for response to the Office Action dated May 16, 2003, now due to expire August 16, 2003, be extended for two month(s) and set to expire on October 16, 2003.

Please charge the extension fee of \$420.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

10/16/2003 HVUONG1 00000057 500417 09817154  
02 FC:1252 420.00 DA

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**Date: October 15, 2003**